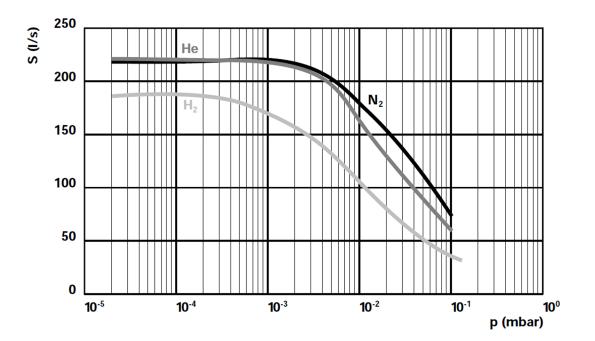


## Pfeiffer TMH-262, TMU-262 Technical Specifications

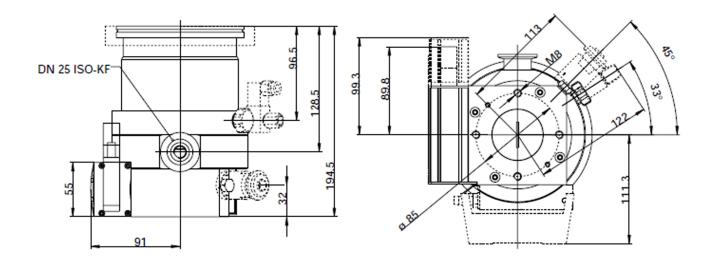
Pumping speed: for N <sub>2</sub>	210 l/s
Pumping speed: for He	220 I/s
Pumping speed: for H <sub>2</sub>	190 l/s
Compression ratio for N <sub>2</sub>	1.10 <sup>9</sup>
Compression ratio for He	3·10 <sup>5</sup>
Compression ratio for H <sub>2</sub>	1.3·10 <sup>4</sup>
Gas throughput for N <sub>2</sub>	7 mbar I/s
Gas throughput for He	6 mbar I/s
Gas throughput for H <sub>2</sub>	3.5 mbar I/s
Ultimate pressure with rotary vane pump	TMH < 1.10 <sup>-7</sup> mbar,
	TMU < 5·10 <sup>-10</sup> mbar
Ultimate pressure with diaphragm pump	TMH < $1.10^{-7}$ mbar
entitude presedure that diapriragin pump	inviti si to modi,
o annaco processi o mar arapin agin pamp	TMU < $1.10^{-8}$ mbar
Recommended backing pump	
	TMU < 1.10 <sup>-8</sup> mbar
	TMU < 1.10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2,
Recommended backing pump	TMU < 1·10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2, DUO 5
Recommended backing pump Rotational speed ±2%	TMU < 1.10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2, DUO 5 60000 1/min
Recommended backing pump Rotational speed ±2% Rotational speed: variable %	TMU < 1.10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2, DUO 5 60000 1/min 20-100
Recommended backing pump Rotational speed ±2% Rotational speed: variable % Run-up time	TMU < 1.10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2, DUO 5 60000 1/min 20-100 3.5 min
Recommended backing pump Rotational speed ±2% Rotational speed: variable % Run-up time Cooling method	TMU < 1.10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2, DUO 5 60000 1/min 20-100 3.5 min water, air
Recommended backing pump Rotational speed ±2% Rotational speed: variable % Run-up time Cooling method Cooling water consumption	TMU < 1.10 <sup>-8</sup> mbar MVP 015-2, MVP 035-2, DUO 5 60000 1/min 20-100 3.5 min water, air 100 I/h



## **Pfeiffer TMH-262, TMU-262** Pumping Curves



#### **Dimensions**



Provac Sales, Inc. 3131 Soquel Drive, Soquel CA 95073



# Pfeiffer TMH-262, TMU-262

### Features & Benefits

- pump and drive form single unit
- simple and economical system solution
- modular design for maximum flexibility
- all components connects on the plug & play principle
- minimal space requirements for the entire system
- integrated serial interface provides additional versatility

### Applications

- semiconductor processes
  thin film coatings
  mass spectrometry
- process gas monitors
  research and development
  UHV technology
- $\cdot \, \mathsf{HV} \, \mathsf{technology} \cdot \mathsf{vacuum} \, \mathsf{processing} \cdot \mathsf{accelerators} \cdot \mathsf{fusion}$

### **Recommended backing pumps**

- Diaphgragm pumps: MVP 015-2 MVP 035-2 MVP 055-3
- Vane pumps; DUO 5